INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 27, 2026

IGI Report Number	LG795668771
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	HEXAGONAL MODIFIED STEP CUT
Measurements	13.06 X 6.93 X 4.35 MM

GRADING RESULTS

Carat Weight	3.04 CARATS
Color Grade	F
Clarity Grade	VVS 2

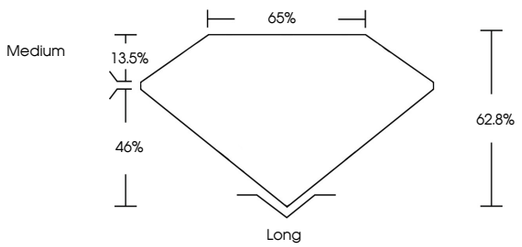
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG795668771

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG795668771
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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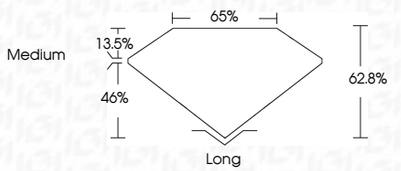
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IGI

April 27, 2026
IGI Report No LG795668771
HEXAGONAL MODIFIED STEP CUT
13.06 X 6.93 X 4.35 MM
Carat Weight 3.04 CARATS
Color Grade F
Clarity Grade VVS 2
Depth 62.8%
Table 65%
Girdle Medium
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG795668771
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa